

Missouri S&T Chemistry Department
Seminar Schedule
Spring Semester 2008

(All seminars are held on Monday at 4:30 p.m. in G-3 Schrenk Hall unless otherwise noted)

Monday, January 14, 2008

Sudhir Mulik, Missouri S&T Graduate Student

Monday, January 21, 2008

No Seminar Martin Luther King Jr. Holiday

Monday, January 28, 2008

Gina Frey, Chemistry Dept. Washington University

Monday, February 4, 2008

Kate Drowne, Writing Seminar

Thursday, February 14, 2008

Manashi Nath, Colorado State University

Monday, February 18, 2008

Thomas Chastek, National Institute of Standards & Technology (NIST)

Thursday, February 21, 2008

Marshall Ming, University of New Hampshire

3:45 refreshments, 4:00 PM Seminar

Monday, February 25, 2008

Bakul Dave, Chemistry Dept. SIU Carbondale

Thursday, February 28, 2008

Wesley Bernskoetter, University of North Carolina, Chapel Hill

Monday, March 3, 2008

Peris Carr, Missouri S&T Graduate Student

Thursday, March 6, 2008

Zhongfang Chen, University of Georgia

Monday, March 10, 2008

John Richard, Chemistry, University of Buffalo

Tuesday, March 18, 2008

Sara J. Risch, Michigan State University (ACS)

Monday, March 24, 2008

Spring Break

Wednesday, April 2, 2008

Shelley Minter, Saint Louis University

Thursday, April 3, 2008

Emma Satterfield, Missouri S&T Graduate Student

2:45 refreshments, 3:00 PM Seminar

Tuesday, April 8, 2008

Nuran Ercal, Chemistry Department, Missouri S&T

Monday, April 14, 2008

Jason W. Cooley, Department of Chemistry, MU

Tuesday, April 15, 2008

Bakul Dave, SIU Carbondale

Monday, April 21, 2008

Christopher T. Culbertson, Department of Chemistry, Kansas State

Wednesday, April 23, 2008

Professor Robert S.H. Liu, University of Hawaii, (ACS)

Thursday, April 24, 2008

Robert Jernigan, Iowa State University

Monday, April 28, 2008

Narayan Hosmane, Department of Chemistry Northern Illinois University

Thursday, May 1, 2008

Daniel Bahaghighat, Missouri S&T Graduate Student

Monday May 5, 2008

Xinsheng Zhang, Missouri S&T Graduate Student